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ICC-273/US
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: :
Hideki Ueno, et al. :) Examiner: NYA
Application No.: 10/656,119 :) Group Art Unit: 1764
Filed: September 8, 2003 :) Confirmation No.: 7055
For: SILICONE RESIN :)
COMPOSITION :) June 14, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 C.F.R. §§ 1.51(b), 1.56, 1.97 and 1.98, Applicants draw the Examiner's attention to the documents that appear listed on the attached Form PTO-1449. Copies of the two listed U.S. patent documents are not included with this Information Disclosure Statement, though copies of the English language abstracts of the remaining non-U.S. patent documents are included.

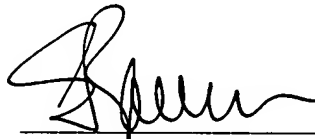
Applicants respectfully request that the listed documents be considered by the Examiner, made of record herein, listed on the "Notice of References Cited" to be issued in this

application and printed on any patent which may issue from this application.

Applicants also respectfully request that a copy of the attached Form PTO-1449, initialed by the Examiner, be returned to Applicants' attorney together with the next communication indicating that the documents have in fact been considered.

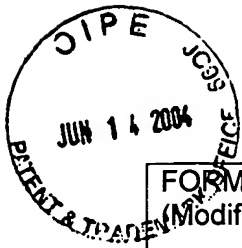
Applicants' undersigned attorney may be reached by telephone at (860) 571-5001 or by facsimile at (860) 571-5028. All correspondence should continue to be directed to the address given below.

Respectfully submitted,

A handwritten signature in black ink, appearing to read 'S. Bauman', written over a horizontal line.

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Attorney for Applicants
Registration No. 33,832

HENKEL CORPORATION
Legal Department
1001 Trout Brook Crossing
Rocky Hill, CT 06067



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| FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE (Modified) PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use Several Sheets if Necessary) <small>(37 CFR 1.96(b))</small> | ATTORNEY DOCKET NO.: ICC-273 | APPLICATION NO.: 10/656,119 |
| | APPLICANT: Hideki Ueno, et al | |
| | FILING DATE: September 8, 2003 | GROUP: 1764 |

| U.S. PATENT DOCUMENTS | | | | | | |
|-----------------------|---------------|------------|----------|-------|-----------|----------------------------|
| EXAMINER'S INITIAL | PATENT NUMBER | ISSUE DATE | PATENTEE | CLASS | SUB CLASS | FILING DATE IF APPROPRIATE |
| | 2,973,334 | 02/1961 | Jack | 260 | 33.6 | |
| | 5,741,839 | 04/1998 | Scheim | 524 | 588 | |
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| | DOCUMENT NUMBER | PUBLICATION DATE | COUNTRY OR PATENT OFFICE | CLASS | SUB CLASS | TRANSLATION | |
|--|-----------------|------------------|--------------------------|-------|-----------|-------------|----------|
| | | | | | | YES | NO |
| | 2002-226708 ✓ | 08/2002 | JP | C08L | 83/06 | | Abstract |
| | 04-076058 ✓ | 03/1992 | JP | C08L | 83/06 | | Abstract |
| | 10-007806 ✓ | 01/1998 | JP | C08G | 77/452 | | Abstract |
| | 11-021443 ✓ | 01/1999 | JP | C08L | 75/00 | | Abstract |
| | 2003-174025 ✓ | 06/2003 | JP | H01L | 21/312 | | Abstract |
| | 2002-053759 ✓ | 02/2002 | JP | C08L | 101/02 | | Abstract |
| | 52-91100 | 08/1977 | JP | C08G | 77/42 | | Abstract |
| | 54-17961 | 09/1979 | JP | C08G | 83-04 | | Abstract |

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| OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication) | | | |
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| EXAMINER: | DATE CONSIDERED: |
| EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant. | |